



2000P1907

Image 1765

CERTIFICATION OF MAILING

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By: _____

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February 10, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/031,706 Confirmation No.: 6354
Applicant : Virinder Grewal, et al.
Filed : January 16, 2002
Art Unit : 1765
Examiner : Duy Vu Nguyen Deo
Title : Gate Etch Process for 12 Inch Wafers
Docket No. : 2000P1907
Customer No. : 24131

R E S P O N S E T O O F F I C E A C T I O N
A M E N D M E N T

Mail Stop Non Fee Amendment
Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S i r :

Responsive to the Office Action dated November 18, 2003
kindly amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of
claims which begins on page 3 of this paper.

Appl. No. 10/031,706

Amdt. Dated February 10, 2004

Reply to Office Action of November 18, 2003

Remarks/Arguments begin on page 9 of this paper.